

An experimental and numerical study of multi-pulse picosecond laser ablation on 316L Stainless Steel

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Abstract: An experimental and numerical study on 10 ps laser ablation of 316L stainless steel up to 400 hundred pulse exposure has been carried out. In this simulation, the material removal threshold temperature has been carefully discussed depending on the different ablation driving mechanisms. The influence of the instantaneous material removal has also been considered which will affect the calculation of the next pulse's absorption. For single-pulse ablation, the simulated ablation threshold $F_{sim}=0.26 \text{ J/cm}^2$ is close to the fitted experimental result $F_{0th}=(0.29 \pm 0.01) \text{ J/cm}^2$. For multi-pulse ablation, the simulated ablation rate $R_{sim}=11.4 \text{ nm/pulse}$ is close to the fitted experimental result $R_{exp}=(12.4 \pm 0.1) \text{ nm/pulse}$ under 0.9 J/cm^2 fluence, while the simulated ablation rate $R_{sim}=19.8 \text{ nm/pulse}$ is slightly larger than the fitted experimental result $R_{exp}=(16.1 \pm 0.7) \text{ nm/pulse}$ at 2.7 J/cm^2 , providing good agreement between theory and experiment for both single and multi-pulse ablation. This study could be used to predict the multi-pulse laser processing performance, especially with the help of a machine learning method to find the best parameters automatically.

1. Introduction

Ultrafast laser whose pulse duration $\tau < 10 \text{ ps}$ has been widely used in areas such as micro cutting [1], surface texturing [2], thin-film processing [3] due to the nature of ultrafast laser-material interactions with minimal heat conduction [4]. During the ultrafast laser ablation, the conduction electrons, excited by the single photon absorption, experience a dramatic increase of electron temperature T_e during the pulse. Then, the electron energy transfers to the lattice through the electron-phonon interaction, leading to a nonequilibrium temperature stage [4, 5] which is widely accepted by using the two-temperature model (TTM) [6] to evaluate.

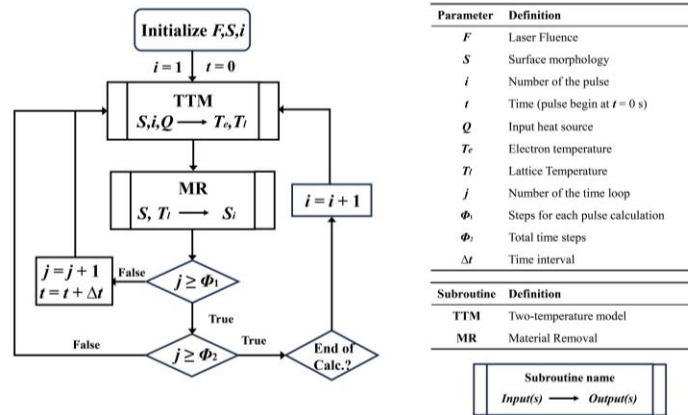
During the past decade, a range of studies on ultrafast laser materials interaction, both theoretical and experimental have been carried out. For example, Metzner et al. [7] and Kumar et al. [8] studied the single pulse ablation on bulk metal by using TTM to predict the ablation depth and radius of single ultrashort pulse laser ablation of 316L stainless steel and Ti6Al4V alloy respectively. The ablation on dielectric materials like fused silica can also be simulated by the TTM [9, 10], as well as the thin-film ablation. For example, Thorstensen and Foss [11] analyze the variation of ablation thresholds when a silicon wafer is under different initial temperatures. Li et al. [12], and Olbrich et al. [13] predicted the ablation depth and radius on different thickness aluminium films, and a 'gentle' and 'strong' ablation crater were found when the film thickness is above 100 nm. Multi-layer thin film ablation can also be carried out. Zhou et al. [14] investigated the laser ablation on gold/glass film which was achieved by setting the electron insulation of electrons and thermal conduction in the glass layer as there are very few free electrons in dielectric materials. As a result, the two-temperature model is a powerful tool for studying the physics during ultrafast laser ablation on both bulk and thin films.

46 However, most of the studies on ultrafast TTM research are based on single-pulse ablation.
 47 For example, Leng et al. [15] integrated the single pulse laser energy and so equivalent to a
 48 multi-pulse for the numerical study. Zhang et al. [16] simulated the multi-pulse ablation on
 49 aluminium by assuming that the material removal rate is independent of pulse number due to
 50 the relatively low laser frequency (1 kHz). More recently, Kumar et al. [17] considered the
 51 material instantaneous removal rate during the simulation, experimentally and numerically
 52 investigating the 1-15 pulses high fluence femtosecond percussion drilling on Ti6Al4V alloy.
 53 Nevertheless, the accuracy of simulations remains challenging as the materials removal
 54 mechanisms and surface morphology changes during ablation will dramatically influence the
 55 accuracy of the simulation.

56 Moreover, the ‘gentle’ and ‘strong’ ablation [13, 18] will occur when ‘low’ and ‘high’ laser
 57 fluence is applied during the ablation. For example, spallation, occurring for the laser fluence
 58 slightly above the ablation threshold at ‘low’ fluence, will induce a high compressive pressure
 59 region under the laser irradiation area [19]. This induced high pressure will lead to the fracture
 60 of multiple nanometer layers and surface expansion in the skin depth which will finally separate
 61 the liquid layer [20, 21]. For high laser fluence, the phase explosion [22, 23] at the material's
 62 thermodynamic critical temperature is more dominant which will result the target into liquid
 63 and vapour droplets [24-26]. Hence the materials removal threshold temperature T_s should be
 64 carefully selected according to the applied laser parameters. In the meantime, the temperature
 65 governs thermo-dynamic parameters such as latent heat of evaporation, coupling factor, thermal
 66 conductivity and developing surface profile which should also be considered to get a more
 67 precise numerical prediction.

68 In this work, an experimental and numerical study on multi-pulse, 10 ps laser ablation of a
 69 polished 316L stainless steel is presented. The instantaneous material removal rate, surface
 70 morphology changes and the ablation threshold temperature were carefully considered to obtain
 71 more precise results yielding good agreement with experimental measurements. This 2D
 72 numerical computation for up to 400 hundred pulse exposure, closer to real-world application,
 73 can be further implemented into the machining learning process [27]. In this case, the desired
 74 results can be automatically chosen and transferred into the next calculation loop, which can
 75 save trial time and reduce manufacturing costs in the industry.

76 2. Methods



77
78 **Fig. 1.** The flowchart of the ablation simulation of 10 ps laser on 316L stainless steel

79 The experiment was carried out on a Nd:YVO₄ seeded regenerative amplifier (High-Q IC-355-
 80 800 ps) laser which gives 5 kHz, 1064 nm, 10 ps linear polarized output beam. The beam energy
 81 was controlled by an attenuator system which is made by a halfwave plate and Glan laser
 82 polarizer. The beam was expanded through a diffraction limited telescope ($M \sim \times 3$) and guided
 83 to the input aperture of a galvo system (Nutfield XLR8-10) via a periscope and focused by a

84 flat-field f-theta lens ($f=100$ mm) on the sample which was supported on x,y,z stages
 85 (Aerotech). The pulse number was controlled by a fast-mechanical shutter (Thorlabs SH05)
 86 and the pulse energy was calibrated under the galvo using a power meter (Coherent, LM-3).
 87 The focal spot size radius ($1/e^2$) is $r_0=(11.1\pm 0.1 \mu\text{m})$, and the input beam diameter (before the
 88 galvo system input aperture) D_{in} is around 8 mm. More experimental details can be found in
 89 [3]. Each experimental data was measured 5 times and a Nikon DS-U2 microscope system
 90 coupled with the microscope NIS-Element D software and a WYKO NT1100 white light
 91 interferometer microscope was used to measure the 2D and 3D profiles of the ablated craters.

92 The numerical model proposed in this research combined TTM and material removal
 93 calculations, achieving by Coefficient from PDE and Deformed Geometry module respectively.
 94 The flowchart of the ablation simulation of 10 ps laser on 316L stainless steel is shown in Fig.
 95 1. When the first pulse ($i=1$) with laser fluence F irradiates on the initial flat surface S , the
 96 amount of energy Q is absorbed in the material. Then, the electron temperature T_e and lattice
 97 temperature T_l will be calculated individually which is detailed in Section 3.1. Once the lattice
 98 temperature is high enough, the material removal stage will occur which is achieved by the
 99 Deformed Geometry function described in the Sec 3.2. The calculation of the i -th pulse's
 100 ablation will be finished when the number of the time loop j is large or equal to the steps for
 101 each pulse calculation Φ_i , and the $i+1$ -th pulse calculation will start with the new surface
 102 morphology S_i . If not, the calculation will continue with a time interval Δt . The whole loop will
 103 be finished until the calculated time step j is large or equal to the total time step Φ_2 .

104 3. Numerical Modelling

105 3.1 Two temperature model

106 For 10 ps laser ablation in this work, the two-temperature model (TTM) [6] is used to predict
 107 the temporal and spatial distribution of the electron and lattice temperatures throughout the
 108 ablation. For a 2D axisymmetric case, the physical model is governed by the equations:

$$109 \quad C_e \frac{\partial T_e}{\partial t} = \nabla \cdot (k_e \nabla T_e) - G(T_e - T_l) + S(r, z, t) \quad (1)$$

$$110 \quad C_l \frac{\partial T_l}{\partial t} = \nabla \cdot (k_l \nabla T_l) + G(T_e - T_l) \quad (2)$$

$$111 \quad \nabla = \left[\frac{\partial}{\partial r}, \frac{\partial}{\partial z} \right] \quad (3)$$

112 where r is the distance from the laser spot centre and z is the penetration depth from the substrate
 113 surface. C_e/C_l and k_e/k_l represent the heat capacity and thermal conductivity of electron and
 114 lattice while T_e and T_l are the temperatures of electron and lattice, respectively. G is the
 115 electron-lattice coupling coefficient, and $Q(r, z, t)$ represents the absorbed laser heating source
 116 which can be described as [28]:

$$117 \quad Q(r, z, t) = (1 - R) \frac{F}{t_p} \exp\left(-2 \frac{r^2}{r_0^2}\right) \cdot \exp\left(-4 \ln 2 \frac{(t - t_0)^2}{(t_p)^2}\right) \exp(-\alpha z) \quad (4)$$

118 in which F is laser fluence, R is material reflectivity, t_p is temporal pulse length, r_0 is the $1/e^2$
 119 radius of the laser beam, t_0 is the time when pulse peak arrives and α is the absorption coefficient
 120 of 316 Stainless Steel.

121 The numerical change of the phase state is considered by combining the latent heat of fusion
 122 H_M and vaporization H_V in the volumetric heat capacity of the lattice [13],

$$C_l = \rho \cdot \left[C_{l0} + \frac{H_M}{\Delta T \cdot \sqrt{2\pi}} \cdot e^{-\frac{1}{2} \left(\frac{T_l - T_M}{\Delta T} \right)^2} + \frac{H_V}{\Delta T \cdot \sqrt{2\pi}} \cdot e^{-\frac{1}{2} \left(\frac{T_l - T_V}{\Delta T} \right)^2} \right] \quad (5)$$

where C_{l0} represents the heat capacity constant of the material, and $\Delta T = 50$ K is used, which determines the width of the zone of phase change. T_M and T_V are the melting and vaporization temperatures, respectively.

The volumetric heat capacity of the electron C_e , coupling factor G and electron thermal conductivity k_e can be approximated as [7, 29]:

$$C_e = \left[2.677 \times 10^6 \exp(8.937 \times 10^{-6} \frac{T_e}{K}) + 2.987 \times 10^6 \exp(3.787 \times 10^{-4} \frac{T_e}{K}) \right] JK^{-1}m^{-3} \quad (6)$$

$$G = \left[2.837 \times 10^{18} \exp \left(- \left(\frac{\frac{T_e}{K} - 3007}{1.166 \times 10^4} \right)^2 \right) + 2.993 \times 10^{18} \exp \left(- \left(\frac{\frac{T_e}{K} - 2.998 \times 10^4}{8.147 \times 10^4} \right)^2 \right) \right] WK^{-1}m^{-3} \quad (7)$$

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$$k_e = \left[\left(0.535 \times \frac{10^4 T_e}{K} - 0.004 \right) \times 10^3 \right] WK^{-1}m^{-1} \quad (8)$$

The reflectance of stainless steel depends on the irradiation laser wavelength, electron temperature and the optical properties of Fe, Cr and Ni [30]. By weighting the percentage of major elements of 316L (Fe70Cr17Ni13), the reflectance R can be given by [7]:

$$R = \left[11 \exp \left(- \frac{0.00013 T_e}{K} \right) + 59.2 \right] \% \quad (9)$$

Note that the reflectivity R was calculated up to an electron temperature of 25×10^3 K [29, 30]. The material parameters for solving TTM are given in Table 1. For the case that no data are available for stainless steel, the data for iron is used instead.

3.2 Axisymmetric model building

In order to save the computation time, a 2D axisymmetric finite element model was built through COMSOL 5.2. The computation domain was set as $40 \mu m \times 10 \mu m$ with 80×100 elements in r and z direction respectively, and both directional element ratio was set to 5, as shown in Fig. 2. Zero flux boundary conditions were set on the right and bottom surface of the computation domain. The symmetric axis was adopted to the Gaussian distribution center of the input laser, and the laser source was irradiated at the top surface of the domain for the first pulse ablation. However, the changeable domain surface will influence the start surface of the Beer-Lambert law. In this case, a modification of the Beer-Lambert law in Eq. (4) has changed into,

$$Q(r, z, t) = (1 - R) \frac{F}{t_p} \exp \left(-2 \frac{r^2}{r_0^2} \right) \cdot \exp \left(-4 \ln 2 \frac{(t - t_0)^2}{(t_p)^2} \right) \exp \left(-\alpha \cdot \text{abs}(z - D_{S_i}(r)) \right) \quad (10)$$

where $\text{abs}(z - D_{S_i}(r))$ means the absolute value of the expression, S_i is the i -th pulse surface morphology and $D_{S_i}(r)$ means the ablated depth D at a distance r on the radial direction of the domain of the S_i .

The depth of the focus $Z_F = \frac{2.56 M^2 \lambda f^2}{D_{in}^2} \approx 1 \text{ mm}$, which is much larger than the μm scale in ablation depth of this work so that the spot size and incident laser intensity distribution were considered constant during the multi pulse ablation simulation. The deformed geometry module

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157 was used to simulate the instant material removal during the processing. Prescribed Normal
 158 Mesh Velocity was added at the material top surface to estimate the deformation velocity of
 159 grid, v_{deform} , which can be determined by the energy balance at the top surface as [31]:

$$160 \quad v_{deform} = \mathbf{V}_{deform} \cdot \mathbf{n} = \frac{F_{vap}}{\rho \cdot H_v} \quad (11)$$

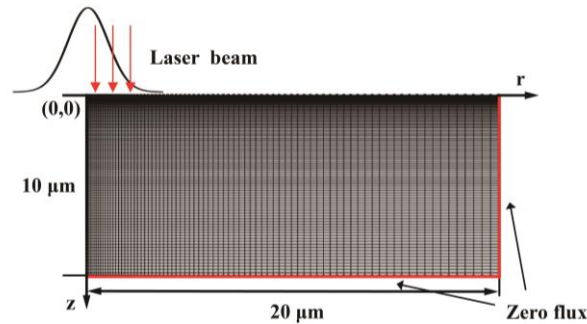
161 in which case \mathbf{V}_{deform} is the velocity of the matter leaving the interface, \mathbf{n} means the normal
 162 vector of surface, and H_v is the latent heat of evaporation, and the thermal boundary condition
 163 F_{vap} can be governed by the ablative heat flux condition which is defined as:

$$164 \quad F_{vap} = h(T) \cdot (T - T_s) \quad (12)$$

165 where T_s is the threshold temperature, and $h(T)$ is a temperature-dependent heat transfer
 166 coefficient, while $h(T)=0$ for $T < T_s$ and increases linearly as $T > T_s$. The $h(T)$ is a slope function
 167 with a steep slope, enforcing that the temperature of the solid cannot markedly exceed the
 168 ablation temperature. Note that both evaporation temperature T_v [32] and the phase explosion
 169 at the materials thermodynamic critical temperature (T_c) [24, 25] were used as threshold value
 170 T_s depending on incident fluence.

171 **Table 1. Laser parameters and thermo-physical properties of 316L Stainless Steel [33-36]**

	Parameter	Value
Laser parameters	Laser fluence F [J/cm^2]	0.9, 1.8, 2.7...
	Wavelength λ [nm]	1064
	Radius w_0 [μm]	11.1
	Pulse duration t_p [ps]	10
Thermo-physical parameters of 316L Stainless Steel	Coefficient of electron heat capacity k_0 [$J m^{-3} K^{-1}$]	134.5
	Absorption coefficient α [m^{-1}]	5.3e7
	Specific heat capacity C_{10} [$J kg^{-1} K^{-1}$]	450
	Thermal conductivity of lattice k_l [$W m^{-1} K^{-1}$]	23
	Critical Temperature T_c [K]	9324
	Fermi Temperature T_f [K]	1.28e5
	Electron-lattice coupling at room temperature g_0 [$W m^{-3} K^{-1}$]	2.45e17
	Melting temperature T_m [K]	1881
	Evaporation temperature, T_v [K]	3300
	Latent heat of fusion, H_M [kJ/kg]	2.47e5
Evaporation enthalpy, H_v [kJ/kg]	6.36e6	
Density, ρ_{Al} [$kg m^{-3}$]	7950	



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Fig. 2. The geometric model of 316 L stainless steel and boundary conditions

174 **4. Results and discussion**

175 **4.1 Experimental results**

176 The ablation threshold on stainless steel was measured using the following equations [37],

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$$D^2 = 2r_0^2 \ln \left(\frac{F_0}{F_{th}} \right) \quad (13)$$

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$$F_0 = \frac{2E_p}{\pi r_0^2} \quad (14)$$

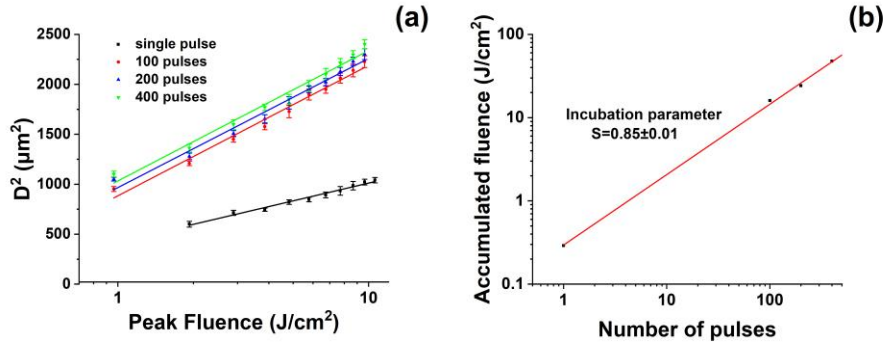
179 where D is the measured ablated crater diameter, r_0 is the laser spot radius, F_{th} is the ablation
 180 threshold, F_0 is the peak fluence and E_p is the pulse energy. Both single-pulse ablation and
 181 multi-pulse ablation were measured, and the pulse energy was set as $E_p=4 \mu\text{J}$, $6 \mu\text{J}$, ..., $22 \mu\text{J}$.
 182 For multi-pulse ablation calculation, the ablated radius D was measured with the pulse energy
 183 $E_p=2.0 \mu\text{J}$, $4.0 \mu\text{J}$, ..., $20.0 \mu\text{J}$ and pulse number $N = 1, 100, 200$ and 400 pulses, respectively.

184 A plot of D^2 versus E_p is shown in Fig. 3(a), each data point was measured 5 times and error
 185 bars represent 1σ . The single pulse ablation threshold was fitted according to the model as $F_{th0(1)}$
 186 $= (0.29 \pm 0.01) \text{ J/cm}^2$, which is close to Jaeggi et al. [38] result whose $F_{th0}=0.31 \text{ J/cm}^2$ and Zhao
 187 et al. [40] result whose $F_{th0}=0.28 \text{ J/cm}^2$ under the 10ps, 1064nm laser's irradiation. Similarly,
 188 the ablation thresholds of multi-pulse ablation were fitted as $F_{th0}(100)=(0.16 \pm 0.01) \text{ J/cm}^2$,
 189 $F_{th0}(200)=(0.14 \pm 0.01) \text{ J/cm}^2$ and $F_{th0}(400)=(0.12 \pm 0.01) \text{ J/cm}^2$.

190 The incubation model describes the relationship between the single-pulse ablation threshold
 191 $F_{th0}(1)$ and the multi-pulse ablation threshold $F_{th}(N)$ in form [39]

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$$F_{th}(N) = F_{th}(1) \cdot N^{S-1} \quad (15)$$

193 where S is the incubation coefficient and is measured as $S=(0.85 \pm 0.01)$, shown in Fig 3(b).
 194 The typical values of S in the range between 0.8 and 0.9 were found with this method in the
 195 case of multi-shot laser ablation of metals at relatively low repetition rates ($< 100 \text{ kHz}$) [40-42]
 196 and close to the value, $S=0.858$ measured by Zhao et al. [39].



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 198 **Fig. 3.** The ablation threshold measurements of 10 ps 1064 nm laser on 316L Stainless steel (a)
 199 Graph of squared ablation diameter D^2 versus E_p for the single, 100, 200 and 400 pulse ablation
 200 (b) The incubation coefficient factor for 10 ps, 1064 nm, 5 kHz ablation on 316L Stainless Steel

201 The optical images and cross section profiles of multi-pulse ablation at fluence $F=0.9 \text{ J/cm}^2$
 202 and 2.7 J/cm^2 are shown in Fig 4. The spherically symmetric dark areas surrounding the ablation
 203 pits is due to the backward flux re-deposition during the multi-pulse ablation [43]. The ablated
 204 depth increases with pulse number, and a linear relationship could be found in both cases. The
 205 ablation depths were measured to be as follows: $D_{ab}=(0.91 \pm 0.10) \mu\text{m}$, $(2.16 \pm 0.13) \mu\text{m}$, $(4.61$
 206 $\pm 0.16) \mu\text{m}$ for laser fluence $F = 0.9 \text{ J/cm}^2$, and for laser fluence $F=2.7 \text{ J/cm}^2$, $D_{ab}=(1.64 \pm 0.09)$
 207 μm , $(3.39 \pm 0.12) \mu\text{m}$, $(6.27 \pm 0.29) \mu\text{m}$ at 100, 200 and 400 pulses respectively.

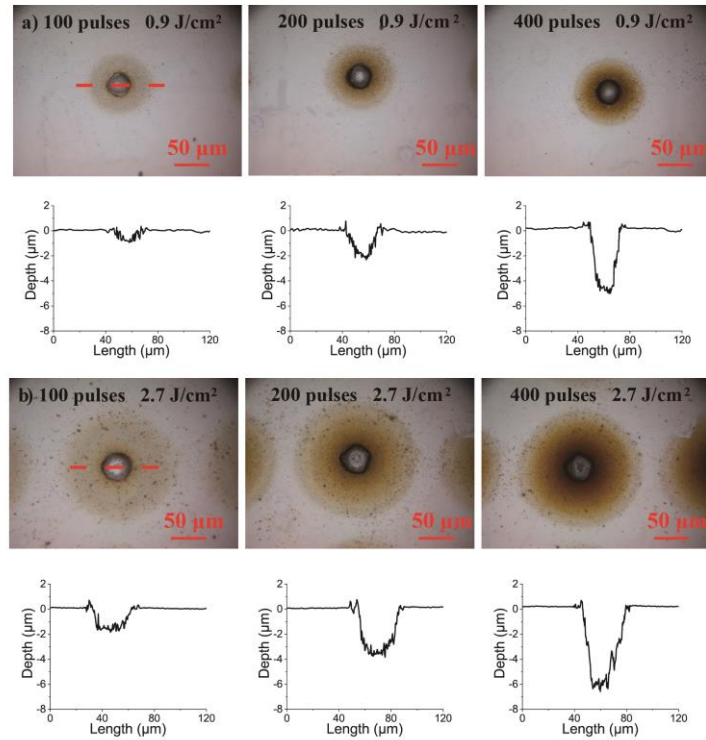


Fig. 4. The optical images and cross section profile of 10 ps laser ablation on 316L Stainless Steel at 100, 200 and 400 pulses. (a) $F=0.9 \text{ J/cm}^2$ (b) 2.7 J/cm^2

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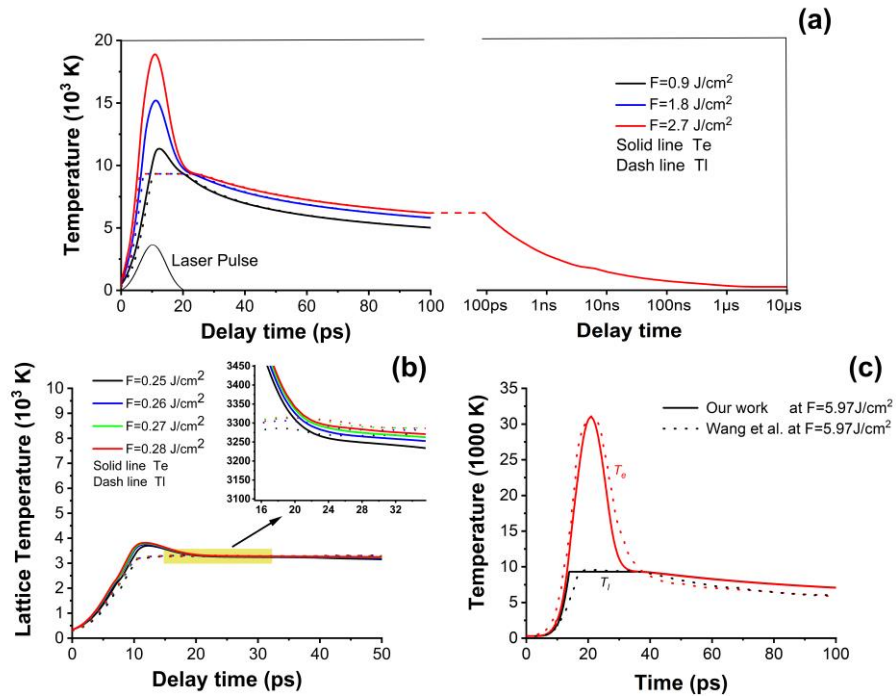
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211 4.2 Numerical results

212 In this work, a range of laser fluence were used. Due to the different driving mechanisms
 213 (spallation and phase explosion) at ‘low’ and ‘high’ laser fluence, the threshold temperature T_s
 214 in Eq. (12) should be carefully considered. The threshold temperature T_s was first set as the
 215 material’s thermodynamic critical temperature T_c for all fluence, $T_s = T_c$, and the electron and
 216 lattice temperature along with a time scale of 100 ps at center point (0,0) in Fig. 1 was calculated
 217 and shown in Fig. 5(a). The corresponding calculated maximum electron temperature $T_e =$
 218 11,300 K, 15,200 K, 18,900 K while the lattice temperature takes 10.3 ps, 7.2 ps, 6.1 ps to reach
 219 the critical temperature of the stainless steel at fluence $F = 0.9, 1.8$ and 2.7 J/cm^2 , respectively.
 220 When laser fluence $F=0.9 \text{ J/cm}^2$, the maximum $T_e=11300 \text{ K}$ which is close to the $T_s=9324 \text{ K}$.
 221 There will be only a small amount of the material reaches the T_c while the rest of the materials
 222 remain the solid or liquid state. In this case, it may not be physically reasonable to use T_c as
 223 threshold temperature for material removal. Moreover, at ‘low’ fluence regime, the spallation
 224 is predominated, and the materials are removed mainly by the laser-induced pressure [20, 21].
 225 When ‘high’ laser fluence $F \geq 0.9 \text{ J/cm}^2$ is applied, the maximum T_e is much larger than the
 226 critical temperature T_c and the lattice temperature T_l indicates a mixture of liquid and gas
 227 material whose phenomena is predominated by the phase explosion. In this case, the threshold
 228 temperature T_s is set as the evaporation temperature, $T_s=T_v=3300\text{K}$ while the laser fluence $F <$
 229 0.9 , and $T_s=T_c=9324 \text{ K}$ when laser fluence $F \geq 0.9 \text{ J/cm}^2$. In addition, a logarithmic form of
 230 temperature-time dependence in a second periodic (100 ps – 10 μs) when the laser fluence
 231 $F=2.7 \text{ J/cm}^2$ is also shown in Fig. 5(a). It could be seen that the lattice and electron temperature
 232 both reached the room temperature at 7.27 μs whereas the inter-pulse period is 0.2 ms in this
 233 work. Therefore, the possible heat accumulation in the multi-pulse ablation has not been
 234 considered in this simulation.

235 The lattice and electron temperature at ‘low’ laser fluence near the ablation threshold are
 236 calculated to test this assumption, and the fluence where the lattice temperature just reaches the
 237 evaporation temperature T_v is considered as the ablation threshold for 316L stainless steel. Fig.
 238 5(b) shows the electron and lattice temperature with an inset yellow region, enlarged. The lattice
 239 temperature just rises above the evaporation temperature ($T_v = 3300$ K) at the laser fluence
 240 $F=0.26$ J/cm², which is close to the experimental measurement $F_{th0(1)}=(0.29 \pm 0.01)$ J/cm²,
 241 whereas the ablation threshold when critical temperature T_c is used is calculated as $F_{sim}=0.61$
 242 J/cm² (not shown). This simulation result supports our assumption that at ‘low’ laser fluence,
 243 the ablation threshold temperature should be chosen as evaporation temperature T_v instead of
 244 the critical temperature (T_c) which is relevant at ‘high’ laser fluence. To verify the quantity of
 245 the used transport coefficient with the TTM, a comparison of the electron and lattice
 246 temperature along 100 ps with our and Wang et al. [44] work are shown in Fig. 5(c). It could
 247 be seen that our work has a good fit with Wang et al.’s work. The slight difference might
 248 contribute to the constant reflectivity $R = 0.51$ in Wang et al.’s work.



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Fig. 5. The electron and lattice temperature at laser spot center (0,0). (a) laser fluence $F = 0.9$, 1.8 and 2.7 J/cm². (b) laser fluence $F = 0.25, 0.26, 0.27$ and 0.28 J/cm², and ablation threshold is recognized at 0.26 J/cm² due to the lattice temperature at this fluence first reaching the evaporation temperature of the 316L Stainless Steel ($T_v = 3300$ K). (c) A validation of the quantity of the used transport coefficient with the TTM.

255 The distribution of 2D lattice temperature at ‘high’ laser fluence $F=2.7$ J/cm² under multi-
 256 pulse ablation is shown in Fig. 6. At 5 ps delay after the first pulse ablation, the maximum
 257 surface temperature raised to ~ 6500 K, but there is no material removal since the surface
 258 temperature is below the critical temperature, T_c . Then the temperature continues to rise until
 259 T_c at 7.5 ps delay when phase explosion and material removal occurs. An obvious surface
 260 depression can be observed at 25 ps, which is deeper and wider at 50 ps delay, and further
 261 evaporation after 50 ps delay is negligible. In this case, the recessional surface profile of the i -
 262 th pulse at 100 ps is exported as a txt. file and inserted in the $i+1$ -th pulse ablation’s calculation,
 263 as shown in Eq. (10). In this case, a more accurate material removal region can be simulated.
 264 Hence, an iterative calculation can be carried out for higher pulse numbers.

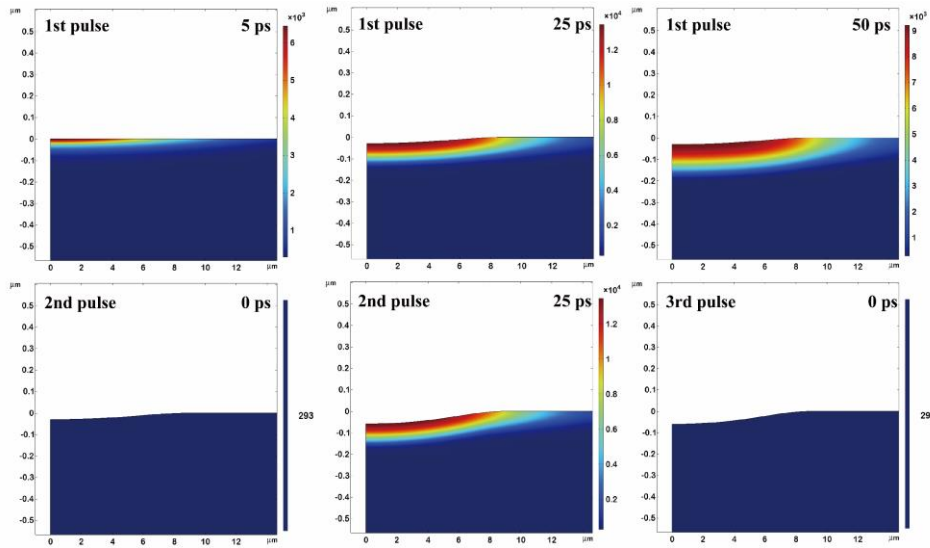


Fig. 6. The temporal distribution of 2D lattice temperature and developing surface profile at laser fluence $F = 2.7 \text{ J/cm}^2$ under 1st, 2nd and 3rd pulse ps ablation.

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268 The developing surface recession at laser fluence $F = 2.7 \text{ J/cm}^2$ under 1st, 50th, 100th, 200th,
269 300th and 400th pulses at 50 ps is shown in Fig. 7. After the first pulse irradiation, a 0.021 μm
270 deep and 8.77 μm radius crater has been formed. Then, the depth increased to 1.03 μm , 2.04
271 μm , 4.03 μm , 6.02 μm , 7.97 μm while the ablation radii increased to 9.33 μm , 10.04 μm , 10.49
272 μm , 10.74 μm , 11.01 μm after 50, 100, 200, 300 and 400 pulse exposure, respectively. In
273 particular, the ablation rate almost follows a linear increase, but the increments of the ablated
274 radius are decreasing which illustrates the incubation effect of multi-pulse ablation.

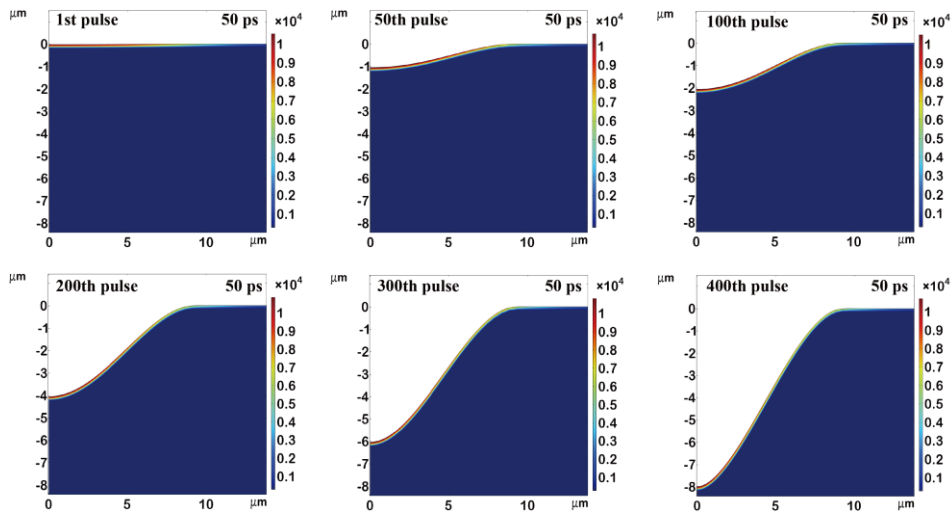


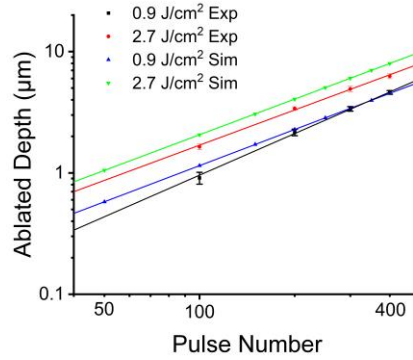
Fig. 7. The surface temperature and recession at laser fluence $F = 2.7 \text{ J/cm}^2$ under 1st, 50th,
100th, 200th, 300th and 400th pulses at 50 ps.

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278 The experiential and numerical ablated rate of 10 ps (1064nm) laser on 316L stainless steel
279 is also compared and shown in Fig. 8. For ‘low’ fluence $F=0.9 \text{ J/cm}^2$, the simulated ablated rate
280 $R_{\text{sim-l}}=11.4 \text{ nm/pulse}$ is close the calculated experimental result $R_{\text{exp-l}}=(12.4 \pm 0.1) \text{ nm/pulse}$. The
281 simulated and experimental ablated depth at 100, 200, 300 and 400 pulses are $D_{\text{sim-l}}=1.15 \mu\text{m}$,
282 2.28 μm , 3.40 μm , 4.52 μm and $D_{\text{exp-l}}=(0.91 \pm 0.10) \mu\text{m}$, $(2.16 \pm 0.13) \mu\text{m}$, $(3.72 \pm 0.14) \mu\text{m}$,

283 (4.61 ± 0.16) μm, respectively. It could be seen that the simulated results were first larger than
 284 the experimental results, then it became lower than the experimental results after 350 pulses
 285 ablation, with good agreement. This change might result in the increased laser absorption due
 286 to the increased effect of surface roughness which is only necessary when the pulse number is
 287 high at low laser fluence [45].



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Fig. 8. Log10-log10 figure of pulse number versus simulated and experimental results of ablation depth under 0.9 J/cm² and 2.7 J/cm² fluence at 10 ps (1064nm @5kHz) laser ablation on 316L Stainless Steel.

292 However, the simulated results at ‘high’ fluence $F=2.7 \text{ J/cm}^2$, $R_{\text{sti-h}}=19.8 \text{ nm/pulse}$, are ~
 293 20% higher than the calculated experimental result $R_{\text{exp-h}}=(16.1 \pm 0.7) \text{ nm/pulse}$, and the
 294 simulated and experimental ablated depth at 100, 200, 300 and 400 pulses exposure are $D_{\text{sim-h}}=2.06 \mu\text{m}$,
 295 $4.05 \mu\text{m}$, $6.04 \mu\text{m}$, $7.99 \mu\text{m}$ and $D_{\text{exp-h}}=(1.64 \pm 0.09) \mu\text{m}$, $(3.39 \pm 0.12) \mu\text{m}$, $(4.92 \pm 0.25) \mu\text{m}$,
 296 $(6.27 \pm 0.29) \mu\text{m}$, respectively. This difference might be caused by the inaccuracy in
 297 calculated reflectivity around and above an electron temperature of 25,000 K [30], while
 298 reflectivity reduces with the increasing pulse number and surface roughness [46]. The backward
 299 flux re-deposition [43] might also reduce the effective ablation rate/pulse, especially at ‘high’
 300 fluence, as ‘thicker’ oxidization layer needs to be removed for multi-pulse ablation[47]. In our
 301 previous study on stainless steel with incident fluence $F=9.0 \text{ J/cm}^2$ and 10 ps pulse length, the
 302 plasma lifetime ($1/e$) was measured as $(9.2 \pm 1.0) \text{ ns}$, yielding an electron temperature $T_e \sim 7500$
 303 K after 40 ns delay [43]. The possible plasma shielding might also influence the final absorption
 304 during the laser ablation which might cause errors in the calculation results.

305 Other physics (for example, spallation, phase transition, stress confinement and density-
 306 dependent collision frequency) which has not been considered in this model, will also bring the
 307 errors into the results. For 316L stainless steel under 10 ps pulse duration, the heating time τ_{heat}
 308 is defined by the pulse duration which is longer than the mechanical expansion time, $\tau_{\text{heat}} \approx \tau >$
 309 τ_{mech} , as the 316L stainless steel’s typical electron-photon interaction time τ_{ep} is around 1-3 ps
 310 [29] and the mechanical expansion time τ_{mech} is around 5 ps [48]. In this case, the low heat
 311 conduction and high electron-phonon coupling will confine the laser energy near the surface,
 312 contributing to the laser-induced stress relaxation and the thermoelastic stress which is large
 313 enough to cause the photomechanical spallation [49]. This photothermal phase explosion can
 314 cause around a 25 % drop in energy specific ablation volume (ESAV) which is the ratio of the
 315 removal volume V_{abl} and the irradiated pulse energy E_p , compared with the ESAV at 0.9 J/cm²
 316 and 2.7 J/cm² under 10 ps pulse duration [48]. Hence, the ablation efficiency will decrease as
 317 the increment of the laser fluence. As our model has not considered the influence of the
 318 spallation and phase explosion, it could bring a relatively large error at ‘high’ fluence.

319 Moreover, the phase transition during the ablation will influence the material’s optical
 320 properties which are related to the varying electron collision frequencies. The electron-electron
 321 collision frequency ν_{ee} is often proportional to the electron temperature $\nu_{ee} \propto T_e^2$ and the

322 electron-ion collision frequency is directly proportional to the lattice temperature $\nu_{ei} \propto T_1$ [50].
323 In this case, the density changes of the 316L stainless steel within lattice temperature, density
324 decrease, and solid-liquid phase transition, all influencing optics via varying collision
325 frequencies which will bring additional differences between the simulation and experiment. It
326 was found that there is a nearly constant upward shift of the effective electron frequency ν_{eff}
327 along with the increase of the electron temperature, and an abrupt increase of the ν_{eff} will occur
328 when the solid material transfer into liquid. reflecting the major decrease of thermal
329 conductivity [51]. This density-dependent collision and plasma frequency will dramatically
330 affect the real part of material dielectric function $\Delta\epsilon_r$ [51] and further influence the total
331 absorption through the ablation. In this case, without considering the density dependence in this
332 model will bring larger errors at high laser fluence, as there is a more obvious density change
333 at high fluence ablation [47]. As a result, without considering the ultrafast laser ablation
334 efficiency by stress confinement [52] and the material's optical properties change due to the
335 density transition [51] will bring the errors in this simulation, and higher errors could be found
336 at 2.7 J/cm² whose absorption has been more impacted as previous discussion.

337 5. Conclusions

338 This method yields encouraging results although representing an approximate picture of the
339 complex ablation process as the single and multiple pulse ablation exposure has been studied
340 experimentally and numerically. The material removal module was used to simulate the
341 instantaneous material removal, which can obtain a more accurate result. Material removal
342 mechanisms such as spallation and phase explosion under different laser fluences have been
343 carefully considered. The threshold temperature T_s was set as evaporation temperature T_s
344 $=T_v=3300$ K for fluence $F < 0.9$ J/cm², and the critical temperature $T_s = T_c=9324$ K for fluence
345 $F \geq 0.9$ J/cm² according to the different ablation driving mechanisms under the 'low' and 'high'
346 laser fluence. In this case, an excellent agreement between experiment and simulation could be
347 achieved as the predicted single pulse ablation threshold $F_{sim}=0.26$ J/cm² is close to the
348 experimental measurement $F_{th}(1)=(0.29\pm 0.01)$ J/cm². The resulting recession surface
349 parameters were used in an iterative procedure to increase the accuracy of the total absorption
350 after multi-pulse exposure. and 1 to 400 pulses ablation were performed with instant material
351 removal at different temporal scales. By using this method, the predicted ablation rate for multi-
352 pulse ablation, $R_{sti-l} = 11.4$ nm/pulse is close to the experimental result $R_{sti-l}=(12.4 \pm 0.1)$
353 nm/pulse at 0.9 J/cm², while at higher laser fluence $F = 2.7$ J/cm², the simulated and calculated
354 experimental ablated rate are $R_{sti-h}=19.8$ nm/pulse and $R_{exp-h}=(16.1 \pm 0.7)$ nm/pulse,
355 respectively. This method is a very versatile tool optimized for variable materials: it works
356 across different industrial applications, for example, thin-film processing, laser-induced
357 periodic spatial structure formation, laser drilling, which can save the trial and error costs in
358 manufacturing. Furthermore, this model can be implemented into the machining learning
359 process [27], which can directly choose the desired results and transfer them into the next
360 calculation.

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366 References

- 367 1. K. L. Włodarczyk, A. Brunton, P. Rumsby, and D. P. Hand, "Picosecond laser cutting and drilling of thin flex
368 glass," *Opt. Laser Eng.* **78**, 64-74 (2016).
369 2. Z. Fang, T. Zhou, W. Perrie, M. Bilton, J. Schille, U. Löschner, S. Edwardson, and G. Dearden, "Pulse Burst
370 Generation and Diffraction with Spatial Light Modulators for Dynamic Ultrafast Laser Materials Processing,"
371 *Mater.* **15**, 9059 (2022).

372 3. T. Zhou, Z. Fang, W. Perrie, Y. Fei, S. Edwardson, and G. Dearden, "Experimental and numerical modelling of
373 picosecond laser ablation of thin aluminium Polyethylene Terephthalate (PET) films," *Opt. Laser Technol.* **151**,
374 107976 (2022).

375 4. K. C. Phillips, H. H. Gandhi, E. Mazur, and S. Sundaram, "Ultrafast laser processing of materials: a review," *Adv.*
376 *Opt. Photonics* **7**, 684-712 (2015).

377 5. B. Mueller, and B. Rethfeld, "Nonequilibrium electron-phonon coupling after ultrashort laser excitation of gold,"
378 *Appl. Surf. Sci.* **302**, 24-28 (2014).

379 6. S. Anisimov, B. Kapeliovich, and T. Perelman, "Electron emission from metal surfaces exposed to ultrashort laser
380 pulses," *Zh. Eksp. Teor. Fiz* **66**, 375-377 (1974).

381 7. D. Metzner, M. Olbrich, P. Lickschat, A. Horn, and S. Weißmantel, "Experimental and theoretical determination
382 of the effective penetration depth of ultrafast laser radiation in stainless steel," *Lasers in Manufacturing and*
383 *Materials Processing* **7**, 478-495 (2020).

384 8. K. K. Kumar, G. Samuel, and M. Shunmugam, "Theoretical and experimental investigations of ultra-short pulse
385 laser interaction on Ti6Al4V alloy," *J. Mater. Process. Tech.* **263**, 266-275 (2019).

386 9. B. Chimier, O. Utéza, N. Sanner, M. Sentsi, T. Itina, P. Lassonde, F. Légaré, F. Vidal, and J.-C. Kieffer, "Damage
387 and ablation thresholds of fused-silica in femtosecond regime," *Phys. Rev. B* **84**, 094104 (2011).

388 10. P. Pan, H. Song, Z. Yang, G. Ren, J. Xiao, X. Chen, and J. Xu, "Thermal field modeling and experimental analysis
389 in laser-assisted machining of fused silica," *Silicon* **13**, 3163-3176 (2021).

390 11. J. Thorstensen, and S. Erik Foss, "Temperature dependent ablation threshold in silicon using ultrashort laser
391 pulses," *J. Appl. Phys.* **112** (2012).

392 12. Q. Li, H. Lao, J. Lin, Y. Chen, and X. Chen, "Study of femtosecond ablation on aluminum film with 3D two-
393 temperature model and experimental verifications," *Appl. Phys. A* **105**, 125-129 (2011).

394 13. M. Olbrich, E. Punzel, R. Roesch, R. Oettking, B. Muhsin, H. Hoppe, and A. Horn, "Case study on the ultrafast
395 laser ablation of thin aluminum films: dependence on laser parameters and film thickness," *Appl. Phys. A* **122**,
396 215 (2016).

397 14. S. Zhou, K. Zhao, and H. Shen, "Ablation of gold film on different substrates by ultrafast laser," *Opt. Laser*
398 *Technol.* **132**, 106495 (2020).

399 15. B. Leng, E. Tang, H. Luo, C. Huang, Y. Han, C. Chen, M. Chang, K. Guo, and L. He, "Research on thermal and
400 mechanical effects of Al/PTFE reactive materials irradiated by femtosecond pulsed laser," *Infrared Phys. Techn.*
401 **119**, 103961 (2021).

402 16. J. Zhang, Y. Chen, M. Hu, and X. Chen, "An improved three-dimensional two-temperature model for multi-pulse
403 femtosecond laser ablation of aluminum," *J. Appl. Phys.* **117** (2015).

404 17. K. Kiran Kumar, G. Samuel, and M. Shunmugam, "An in-depth investigation into high fluence femtosecond laser
405 percussion drilling of titanium alloy," *Proceedings of the Institution of Mechanical Engineers, Part B: Journal of*
406 *Engineering Manufacture* **237**, 601-617 (2023).

407 18. X. Wang, Y. Huang, C. Li, and B. Xu, "Numerical simulation and experimental study on picosecond laser ablation
408 of stainless steel," *Opt. Laser Technol.* **127**, 106150 (2020).

409 19. E. Leveugle, D. S. Ivanov, and L. V. Zhigilei, "Photomechanical spallation of molecular and metal targets:
410 molecular dynamics study," *Appl. Phys. A* **79**, 1643-1655 (2004).

411 20. H. Tamura, T. Kohama, K. Kondo, and M. Yoshida, "Femtosecond-laser-induced spallation in aluminum," *J. Appl.*
412 *Phys.* **89**, 3520-3522 (2001).

413 21. C. Wu, M. S. Christensen, J.-M. Savolainen, P. Balling, and L. V. Zhigilei, "Generation of subsurface voids and a
414 nanocrystalline surface layer in femtosecond laser irradiation of a single-crystal Ag target," *Phys. Rev. B* **91**,
415 035413 (2015).

416 22. C. Phipps, *Laser ablation and its applications* (Springer, 2007).

417 23. E. G. Gamaly, "The physics of ultra-short laser interaction with solids at non-relativistic intensities," *Phys. Reports*
418 **508**, 91-243 (2011).

419 24. D. A. Willis, and X. Xu, "Heat transfer and phase change during picosecond laser ablation of nickel," *Int. J. Heat*
420 *Mass Tran.* **45**, 3911-3918 (2002).

421 25. S. Wang, Y. Ren, C.-W. Cheng, J. Chen, and D. Tzou, "Micromachining of copper by femtosecond laser pulses,"
422 *Appl. Surf. Sci.* **265**, 302-308 (2013).

423 26. B. Wu, and Y. C. Shin, "A simple model for high fluence ultra-short pulsed laser metal ablation," *Appl. Surf. Sci.*
424 **253**, 4079-4084 (2007).

425 27. S. Chugh, S. Ghosh, A. Gulistan, and B. Rahman, "Machine learning regression approach to the nanophotonic
426 waveguide analyses," *J. Lightwave Technol.* **37**, 6080-6089 (2019).

427 28. X. Wang, C. Ma, C. Li, M. Kang, and K. Ehmann, "Influence of pulse energy on machining characteristics in laser
428 induced plasma micro-machining," *J. Mater. Process. Tech.* **262**, 85-94 (2018).

429 29. E. Bévilion, J.-P. Colombier, B. Dutta, and R. Stoian, "Ab initio nonequilibrium thermodynamic and transport
430 properties of ultrafast laser irradiated 316L stainless steel," *J. Phys. Chemistry C* **119**, 11438-11446 (2015).

431 30. E. Bévilion, R. Stoian, and J.-P. Colombier, "Nonequilibrium optical properties of transition metals upon ultrafast
432 electron heating," *J. Phys.: Condens. Matter* **30**, 385401 (2018).

433 31. L. Ben-Mahfoud, E. Silaeva, R. Stoian, and J.-P. Colombier, "Structural instability of transition metals upon
434 ultrafast laser irradiation," *Phys. Rev. B* **104**, 104104 (2021).

435 32. L. Chen, Z. Chen, K. Shimada, M. Mizutani, and T. Kuriyagawa, "Electric field analysis coupled with the two-
436 temperature model to elucidate the generation process of laser-induced periodic surface structure," *J. Mater.*
437 *Process. Tech.* **305**, 117601 (2022).

438 33. C. A. Dold, *Picosecond laser processing of diamond cutting edges* (ETH Zurich, 2013).

439 34. J. J. Valencia, and P. Quedsted, "Thermophysical properties," *Modeling for casting and solidification processing*
440 **189** (2001).

441 35. B. J. Simonds, J. Sowards, J. Hadler, E. Pfeif, B. Wilthan, J. Tanner, C. Harris, P. Williams, and J. Lehman, "Time-
442 resolved absorptance and melt pool dynamics during intense laser irradiation of a metal," *Phys. Rev. Appl.* **10**,
443 044061 (2018).

444 36. M. Palengat, G. Chagnon, D. Favier, H. Louche, C. Linardon, and C. Plaideau, "Cold drawing of 316L stainless
445 steel thin-walled tubes: experiments and finite element analysis," *Int. J. Heat Mass Tran.* **70**, 69-78 (2013).

446 37. J. Liu, "Simple technique for measurements of pulsed Gaussian-beam spot sizes," *Opt. Lett.* **7**, 196-198 (1982).

447 38. B. Jaeggi, B. Neuenschwander, M. Schmid, M. Murali, J. Zuercher, and U. Hunziker, "Influence of the pulse
448 duration in the ps-regime on the ablation efficiency of metals," *Phys. Procedia* **12**, 164-171 (2011).

449 39. W. Zhao, W. Wang, G. Jiang, B. Q. Li, and X. Mei, "Ablation and morphological evolution of micro-holes in
450 stainless steel with picosecond laser pulses," *Int. J. Adv. Manuf. Tech.* **80**, 1713-1720 (2015).

451 40. G. Raciukaitis, M. Brikas, P. Gecys, and M. Gedvilas, "Accumulation effects in laser ablation of metals with high-
452 repetition-rate lasers," in *High-Power Laser Ablation VII*(Spie2008), pp. 725-735.

453 41. P. Mannion, J. Magee, E. Coyne, G. O'connor, and T. Glynn, "The effect of damage accumulation behaviour on
454 ablation thresholds and damage morphology in ultrafast laser micro-machining of common metals in air," *Appl.*
455 *Surf. Sci.* **233**, 275-287 (2004).

456 42. F. Di Niso, C. Gaudiuso, T. Sibillano, F. Mezzapesa, A. Ancona, and P. Lugarà, "Influence of the repetition rate
457 and pulse duration on the incubation effect in multiple-shots ultrafast laser ablation of steel," *Phys. Procedia* **41**,
458 698-707 (2013).

459 43. T. Zhou, S. Kraft, W. Perrie, J. Schille, U. Löschner, S. Edwardson, and G. Dearden, "Backward flux re-deposition
460 patterns during multi-spot laser ablation of stainless steel with picosecond and femtosecond pulses in air," *Mater.*
461 **14**, 2243 (2021).

462 44. X. Wang, Y. Huang, C. Li, and B. Xu, "Numerical simulation and experimental study on picosecond laser ablation
463 of stainless steel" *Opt. Laser Technol* 127106150 (2020).

464 45. H. Mustafa, M. Mezera, D. T. A. Matthews, and G. Römer, "Effect of surface roughness on the ultrashort pulsed
465 laser ablation fluence threshold of zinc and steel," *Appl. Surf. Sci.* **488**, 10-21 (2019).

466 46. C. McDaniel, A. Flanagan, and G. M. O'Connor, "Evidence for increased incubation parameter in multi-pulse
467 ablation of a Pt: SS alloy using a femtosecond laser at high repetition rates," *Appl. Surf. Sci.* **295**, 1-7 (2014).

468 47. J. Winter, S. Rapp, M. Spellaue, C. Eulenkamp, M. Schmidt, and H. P. Huber, "Ultrafast pump-probe ellipsometry
469 and microscopy reveal the surface dynamics of femtosecond laser ablation of aluminium and stainless steel," *Appl.*
470 *Surf. Sci.* **511**, 145514 (2020).

471 48. J. Winter, M. Spellaue, J. Hermann, C. Eulenkamp, H. P. Huber, and M. Schmidt, "Ultrashort single-pulse laser
472 ablation of stainless steel, aluminium, copper and its dependence on the pulse duration," *Opt. Express* **29**, 14561-
473 14581 (2021).

474 49. L. V. Zhigilei, Z. Lin, and D. S. Ivanov, "Atomistic modeling of short pulse laser ablation of metals: connections
475 between melting, spallation, and phase explosion," *J. Phys. Chem. C* **113**, 11892-11906 (2009).

476 50. P. M. Chaikin, T. C. Lubensky, and T. A. Witten, *Principles of condensed matter physics* (Cambridge university
477 press Cambridge, 1995).

478 51. J. Winter, D. Redka, J. Minár, M. Schmidt, and H. P. Huber, "Resolving transient temperature and density during
479 ultrafast laser ablation of aluminum," *Appl. Phys. A* **129**, 665 (2023).

480 52. D. Redka, J. Winter, C. Gadelmeier, A. Djuranovic, U. Glatzel, J. Minár, and H. P. Huber, "Control of ultrafast
481 laser ablation efficiency by stress confinement due to strong electron localization in high-entropy alloys," *Appl.*
482 *Surf. Sci.* **594**, 153427 (2022).